

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Andreas et al.

Serial No.: 10/645,710

Filed: August 21, 2003

For: WAFER CLEANING METHOD AND

RESULTING WAFER

Confirmation No.: 8457

Examiner: Tu Tu V. Ho

Group Art Unit: 2818

Attorney Docket No.: 2269-5663US

(02-1325.00/US)

Notice of Allowance Mailed:

January 26, 2005

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents,

P.O. Box 1450, Alexandria, VA 22313-1450.

February 25, 2005

Date

Leah J. Barrow

Name (Type/Print)

AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)

Mail Stop ISSUE FEE Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows:

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 6 of this paper.

Remarks begin on page 12 of this paper.